

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	59	recovery adj tool and substrate	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 16:37
L2	10	recovery adj tool and substrate and inspection	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 16:38
L3	3	(US-20090151480-\$. did. or (WO- 2005073692-\$ or EP- 1710555-\$.).did.	US-PGPUB; EPO	OR	ON	2009/09/27 16:41
L4	3	3 and recovery adj tool	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 16:42
L5	3	recovery adj tool with (drop droplet sphere)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 16:43
L6	152	substrate near3 inspect\$3 same (drop droplet sphere)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 16:59
L7	2	substrate near3 inspect\$3 with (tube cylindrical cone conical) same (drop droplet sphere)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:00
L8	2	substrate with inspect \$3 with (tube cylindrical cone conical) same (drop droplet sphere) and recovery	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:33
L9	872	substrate with impurit \$3 same (drop droplet sphere)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:35

L10	844	substrate with impurit \$3 same (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:35
L11	707	semiconductor and substrate with impurit \$3 same (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:35
L12	330	semiconductor with substrate with impurit \$3 same (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:35
L13	140	semiconductor with substrate with impurit \$3 with (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:35
L14	17	semiconductor with substrate with surface near2 impurit \$3 with (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:39
L15	8	("5395446").URPN.	USPAT	OR	ON	2009/09/27 17:40
L16	23	("3760822" "3810779" "3933187" "4060097" "4075974" "4501527" "4564280" "4584886" "4634497" "4695327" "4705951" "4746256" "4790262" "4800836" "4816638" "4822639" "4827954" "4838979" "4886412" "4891087" "4891488" "4944860").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2009/09/27 17:41

L17	15	(US-20090151480-\$). did. or (US-7471762-\$ or US-5633172-\$ or US-5527707-\$ or US- 5395446-\$ or US- 4564280-\$).did. or (WO-2005073692-\$ or EP-1710555-\$). did. or (JP- 2005236145-\$ or JP- 2000332072-\$ or JP- 2000186988-\$ or JP- 11166882-\$ or JP- 05283498-\$).did. or (JP-2006108364-\$ or JP-2000107672-\$). did.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:54
L18	3	17 and (groove through adj hole)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 17:54
L19	2	17 and negative adj pressure	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 18:43
L20	30	"256749"	JPO; DERWENT	OR	ON	2009/09/27 18:47
L21	1	"05256749"	JPO; DERWENT	OR	ON	2009/09/27 18:48
L22	2	"05283498"	JPO; DERWENT	OR	ON	2009/09/27 18:49
L23	1163	(73/865.8).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	OFF	2009/09/27 19:23
L24	1	23 and (wafer substrate semiconductor) with impuriti\$3 same (drop droplet)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/27 19:24
S1	7	"584822".ap.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/17 13:08
S2	1	S1 and recovery adj tool	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	OR	ON	2009/09/17 13:09

EAST Search History (I nterference)

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 \ 10584822_recovery_tool_GG.wsp**